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MAY 21 2007

XA-10036  
PATENT APPLICATION

RESPONSE UNDER 37 C.F.R. 1.116  
EXPEDITED PROCEDURE - EXAMINING GROUP 2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

First Named Inventor: TAMAKI, YOICHI Art Unit: 2814

Application No.: 10/773,658 Examiner: L. Pham

Filed: February 9, 2004 Conf. No.: 7635

For: SEMICONDUCTOR DEVICE

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RESPONSE AFTER FINAL REJECTION

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This paper is submitted in response to the Office Action dated March 21, 2007, in the above-identified patent application.

Remarks/Arguments begin on page 2 of this paper.